

Notice of References Cited	Application/Control No. 10/568,704	Applicant(s)/Patent Under Reexamination BORTLIK ET AL.	
	Examiner QIUWEN MI	Art Unit 1655	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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